

**Search Notes**

Application/Control No.

10/779,400

Examiner

Raymond Phan

Applicant(s)/Patent under  
Reexamination

IWAMURA, RYUICHI

Art Unit

2111

**SEARCHED**

Class	Subclass	Date	Examiner
710	305-317, 36-38, 62-64,72	7/15/2006	RP
709	201-203	7/15/2006	RP
725	219,74	7/17/2006	RP

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
EAST	7/16/2006	RP